

Thursday 2 June

09:00

Plenary session -Silicon technology for detectors

Session | **Location:** Helsinki, Finland, 0--E204

09:00-09:20 Welcome

Speaker

Mara Bruzzi, Jaakko Haerkoenen and Michael Moll

Location

Helsinki, Finland, 0--E204

09:15-09:40 Manufacture of High Resistivity, Low Oxygen Czochralski Silicon

Speaker

Olli Anttila

Location

Helsinki, Finland, 0--E204

09:40-10:00

Quantitative copper and iron measurement in silicon using contactless recombination lifetime measurements

Speaker

Hele Savin

Location

Helsinki, Finland, 0--E204

10:00